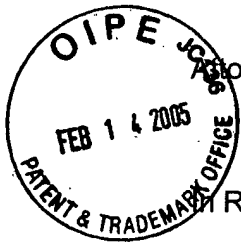


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Attorney's Docket No.: 042390P4220

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Mark T. Bohr

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Filed: December 31, 1997

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Commissioner for Patents
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FORMAL DRAWINGS SUBMISSION

Enclosed herewith for submission in the United States Patent and Trademark Office
are nine (9) sheets of formal drawings for the patent application referenced above.

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Respectfully submitted,

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Dated: 2/11, 2005



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